



85UHP ULTRA-HIGH PURITY

SPECIFICATIONS

- C276 or 316L SS Wetted Surface material – Optional
- Compensated or Uncompensated - optional
- High Vacuum Stability at 10^{-3} Pa
- 0.1%Span/year Long Term Stability
- Absolute Pressure Measurement
- 13mm Diaphragm Diameter

FEATURES

- Hi-Vacuum Stability
- F105 Compliant Wetted Surfaces (Alloy C276 Variants)
- -40°C to +125°C Operating Temperature
- Up to $\pm 0.1\%$ Pressure Non-Linearity
- Solid State Reliability

Model 85UHP is a weldable compact profile, media compatible, pressure sensor, a MEMS piezo-resistive chip integrated in a 316L stainless steel or alloy C276 module with silicone oil filled which transfer pressure from a thin corrugated diaphragm in the front face.

It was designed and manufactured for OEM where customer seeking a semiconductor application process duration that is greater than TE standard 85 ISO capsule, it offers wetted material options and surface roughness optimized for ultra-high purity and ultra-high vacuum scenarios, harnessing TE's advanced MEMS capabilities to deliver unparalleled precision and stability.

APPLICATIONS

- Gas Cabinets
- Mass Flow Controller
- High Purity Gas Delivery system
- Pressure and Flow control in Semiconductor Process

[CLICK HERE ›](#)
CONNECT WITH A SPECIALIST

SPECIFICATIONS - Uncompensated

Unless otherwise specified, Supply Current: 1.5 mA; Ambient Temperature: 25°C

PARAMETERS	MIN	TYP	MAX	UNITS	NOTES
Sensitivity	12	-	27	mV/V@Span	
Zero Pressure Output	-6.0	-	+8.0	mV/V	1
Pressure Non-Linearity	-0.1	-	+0.1	%Span	2
Pressure Hysteresis	-0.05	-	0.05	%Span	
Repeatability	-	±0.02	-	%Span	
Bridge Resistance	3.8K	-	5.8K	Ω	3
Thermal Hysteresis – Span	-0.25	±0.05	0.25	%Span	4
Thermal Hysteresis – Offset	-0.25	±0.05	0.25	%Span	4
Temperature Coefficient – Resistance	1.30K	1.51K	1.75K	PPM/°C	4
Temperature Coefficient – Span	-1.65K	-1.25K	-1.0K	PPM/°C	4
Temperature Coefficient – Offset	-30	-	30	µV/V/°C	
Long Term Stability - Span	-	±0.10	-	%Span/Year	
Long Term Stability - Offset	-	±0.10	-	%Span/Year	
Supply Current	0.5	1.5	2.0	mA	
Supply Voltage	-	5	9.5	V	
Output Noise (10Hz to 1kHz)	-	1.0	-	µV p-p	
Response Time (10% to 90%)	-	0.1	-	ms	
Insulation Resistance (50V _{DC})	50M	-	-	Ω	5
Pressure Overload	-	-	3X	Rated	6
Pressure Burst	-	-	4X	Rated	7
Operating Temperature	-40	-	+125	°C	
Storage Temperature	-40	-	+125	°C	
High Vacuum Stability	Output drift within ±0.1%SPAN/year under vacuum level 10E-3Pa @ 25 °C				
Media – Pressure Port	Liquids and Gases compatible with 316L Stainless Steel or Alloy C276				12

Notes

1. Measured at vacuum for absolute (A).
2. Best fit straight line.
3. Bridge resistance is measured with both -E pins shorted together.
4. TC values are first order coefficients to a quadratic fit over a temperature range of -20°C to 85°C.
5. Between case and sensing element.
6. The maximum pressure that can be applied without changing the transducer's performance or accuracy.
7. The maximum pressure that can be applied to a transducer without rupture of either the sensing element or transducer.
8. Testing:
 - 8.1 Units are not tested over temperature or pressure.
 - 8.2 A final test is performed @ 1.5mA and room temperature for part functionality.
 - 8.3 All units are subjected to 100% drift test.
9. Device Marking:

Part marked with Model Number, Pressure Range, Type, Lot Number, Serial Number and Date Code.
10. Shipping and Packaging:

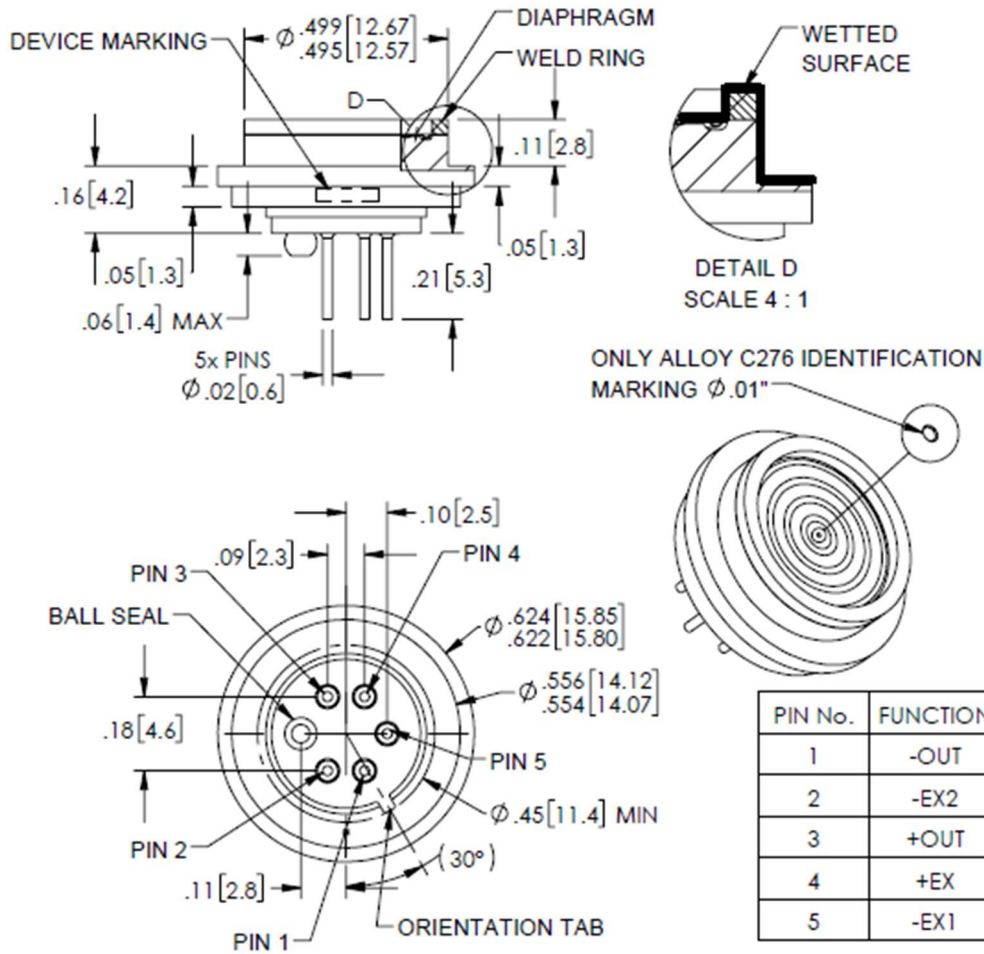
The diaphragm is protected by a static dissipative cap. 32pcs units are secured in a shipping tray vacuumized with ESD bag.
11. Direct mechanical contact with diaphragm is prohibited. Diaphragm surface must remain free of defects (scratches, punctures, dents, fingerprints, etc.) for device to operate properly. Caution is advised when handling parts with exposed diaphragms. Use protective cap whenever devices are not in use.
12. Wetted surface:
 - 12.1 The diaphragm, weld ring and module material (316L SS and Alloy C276) optional, C276 material is Compliant with SEMI F105.
 - 12.2 Indicated wetted surface (not including the welding bead) roughness optional.

85UHP

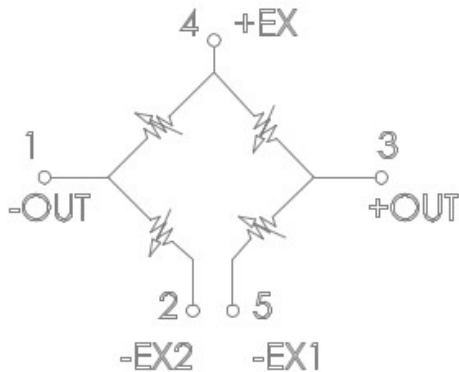
Ultra-high Purity ISO Pressure Capsule

DIMENSIONS - Uncompensated

Dimensions are in inches[mm]



APPLICATION SCHEMATIC - Uncompensated



SPECIFICATIONS - Constant Current Compensated

Unless otherwise specified, Supply Current: 1.5mA; Ambient Temperature: 25°C

PARAMETERS	MIN	TYP	MAX	UNITS	NOTES
Span	75	100	150	mV	
Zero Pressure Output	-1.0	0	1.0	mV	1
Pressure Non Linearity	-0.10	-	0.10	%Span	2
Pressure Hysteresis	-0.05	±0.02	0.05	%Span	
Repeatability	-	±0.02	-	%Span	
Input Resistance	2.0	3.5	5.8	KΩ	
Output Resistance	4.0	-	6.0	KΩ	
Temperature Error – Span	-0.75	-	0.75	%Span	3
Temperature Error – Offset	-0.50	-	0.50	%Span	3
Temperature Error – Offset @15PSI only	-0.75	-	0.75	%Span	3
Thermal Hysteresis – Span	-0.25	±0.05	0.25	%Span	3
Thermal Hysteresis – Offset	-0.25	±0.05	0.25	%Span	3
Long Term Stability – Span	-	±0.10	-	%Span/Year	
Long Term Stability – Offset	-	±0.10	-	%Span/Year	
Supply Current	0.5	1.5	2.0	mA	4
Output Load Resistance	5	-	-	MΩ	5
Insulation Resistance (50V _{DC})	50	-	-	MΩ	6
Output Noise (10Hz to 1KHz)	-	1.0	-	μV p-p	
Response Time (10% to 90%)	-	0.1	-	ms	
Pressure Overload	-	-	3X	Rated	7
Pressure Burst	-	-	4X	Rated	8
Compensated Temperature	-20	-	85	°C	
Operating Temperature	-40	-	125	°C	9
Storage Temperature	-40	-	125	°C	9
High Vacuum Stability	Output drift within ±0.1%SPAN/year under vacuum level 10E-3Pa @ 25 °C				
Media – Pressure Port	Liquids and Gases compatible with 316L Stainless Steel or Alloy C276				13

Notes

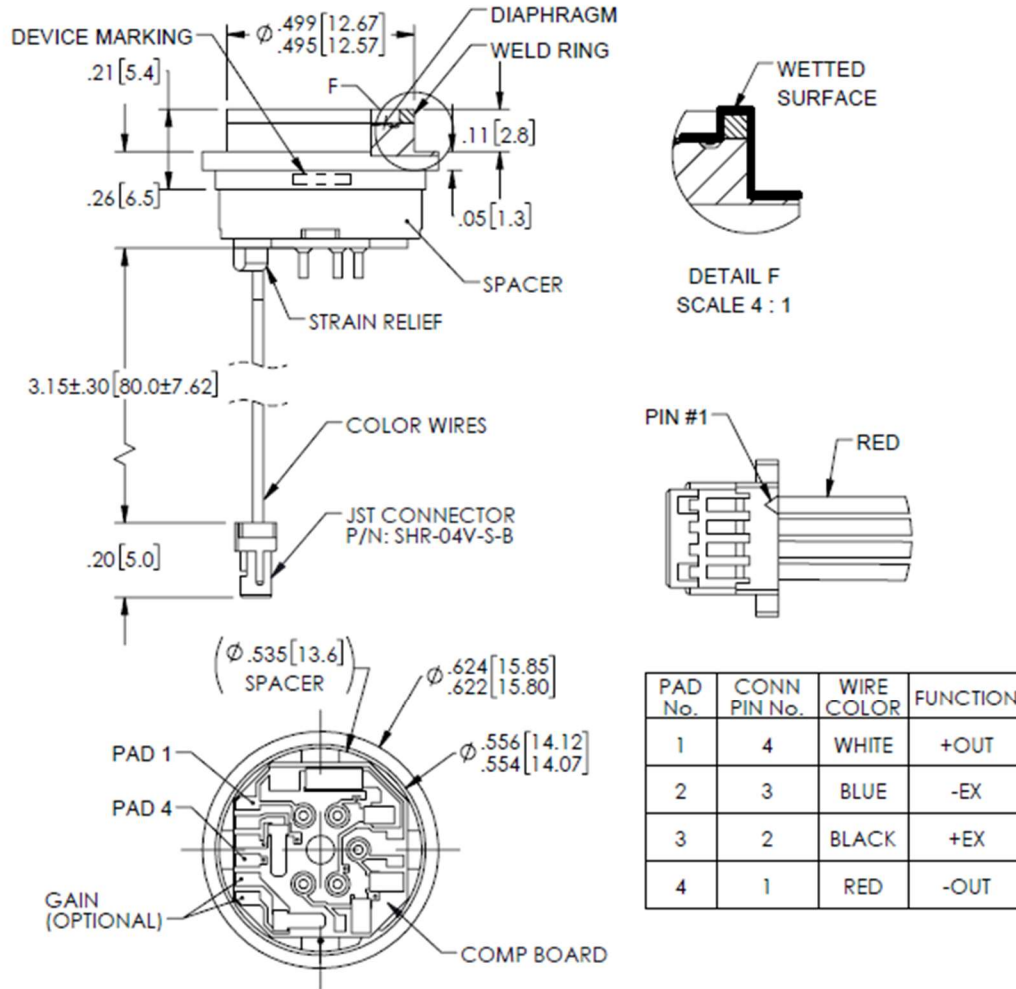
1. Measured at vacuum for absolute (A).
2. Best fit straight line.
3. Over the compensated temperature range with respect to 25°C.
4. Guarantees output/input ratiometricity.
5. Load resistance to reduce measurement errors due to output loading.
6. Between case and sensing element.
7. The maximum pressure that can be applied without changing the transducer's performance or accuracy.
8. The maximum pressure that can be applied to a transducer without rupture of either the sensing element or transducer.
9. Maximum temperature range for product with standard cable and connector is -20°C to +85°C.
10. Device Marking:
Each part shall be identified with Model Number, Pressure Range, Type, Lot Number, Serial Number and Date Code.
11. Shipping/Packaging requirements:
The stainless steel diaphragm is protected by a plastic cap, 32pcs units are secured in a shipping tray vacuumized with ESD bag.
12. Direct mechanical Contact with diaphragm is prohibited. Diaphragm surface must remain free of defects (scratches, punctures, dents, fingerprints, etc) for device to operate properly. Caution is advised when handling parts with exposed diaphragms. Use protective cap whenever devices are not in use
13. Wetted surface:
13.1 The diaphragm, weld ring and module material (316L SS and Alloy C276) optional; C276 material is Compliant with SEMI F105.
13.2 Indicated wetted surface (not including the welding bead) roughness optional.

85UHP

Ultra-high Purity ISO Pressure Capsule

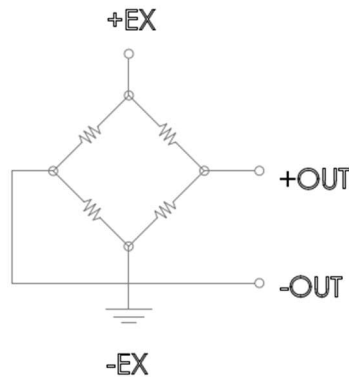
DIMENSIONS- Constant Current Compensated

Dimensions are in inches[mm]



VIEW SHOWN W/O CABLE AND CONNECTOR FOR CLARITY

APPLICATION SCHEMATIC - Constant Current Compensated



EQUIVALENT SCHEMATIC

SPECIFICATIONS - Constant Voltage Compensated

Unless otherwise specified, Supply Voltage: 10 V_{DC}; Ambient Temperature: 25°C

PARAMETERS	All Ranges			UNITS	NOTES
	MIN	TYP	MAX		
Span	99	100	101	mV	1
Zero Pressure Output	-1.0	-	1.0	mV	1
Pressure non-linearity	-0.1	-	0.1	%Span	2
Pressure Hysteresis	-0.05	±0.02	0.05	%Span	
Repeatability	-	±0.02	-	%Span	
Input Resistance	5.5K	9.0K	12.5K	Ω	
Output Resistance	4.0K	-	6.0K	Ω	
Temperature Error – Span	-1.0	-	1.0	%Span	3
Temperature Error – Offset	-1.0	-	1.0	%Span	3
Thermal Hysteresis – Span	-0.25	±0.05	0.25	%Span	3
Thermal Hysteresis – Offset	-0.25	±0.05	0.25	%Span	3
Long Term Stability – Span	-	±0.10	-	%Span/Year	
Long Term Stability – Offset	-	±0.10	-	%Span/Year	
Supply Voltage	5	10	14	V _{DC}	4
Output Load Resistance	5M	-	-	Ω	5
Insulation Resistance (50V _{DC})	50M	-	-	Ω	6
Output Noise (10Hz to 1KHz)	-	1.0	-	μV p-p	
Response Time (10% to 90%)	-	0.1	-	ms	
Pressure Overload	-	-	3X	Rated	7
Pressure Burst	-	-	4X	Rated	8
Compensated Temperature	-20	-	85	°C	
Operating Temperature	-40	-	125	°C	9
Storage Temperature	-40	-	125	°C	9
High Vacuum Stability	Output drift within ±0.1%SPAN/year under vacuum level 10E-3Pa @ 25 °C				
Media – Pressure Port	Liquids and Gases compatible with 316L Stainless Steel or Alloy C276				13

Notes

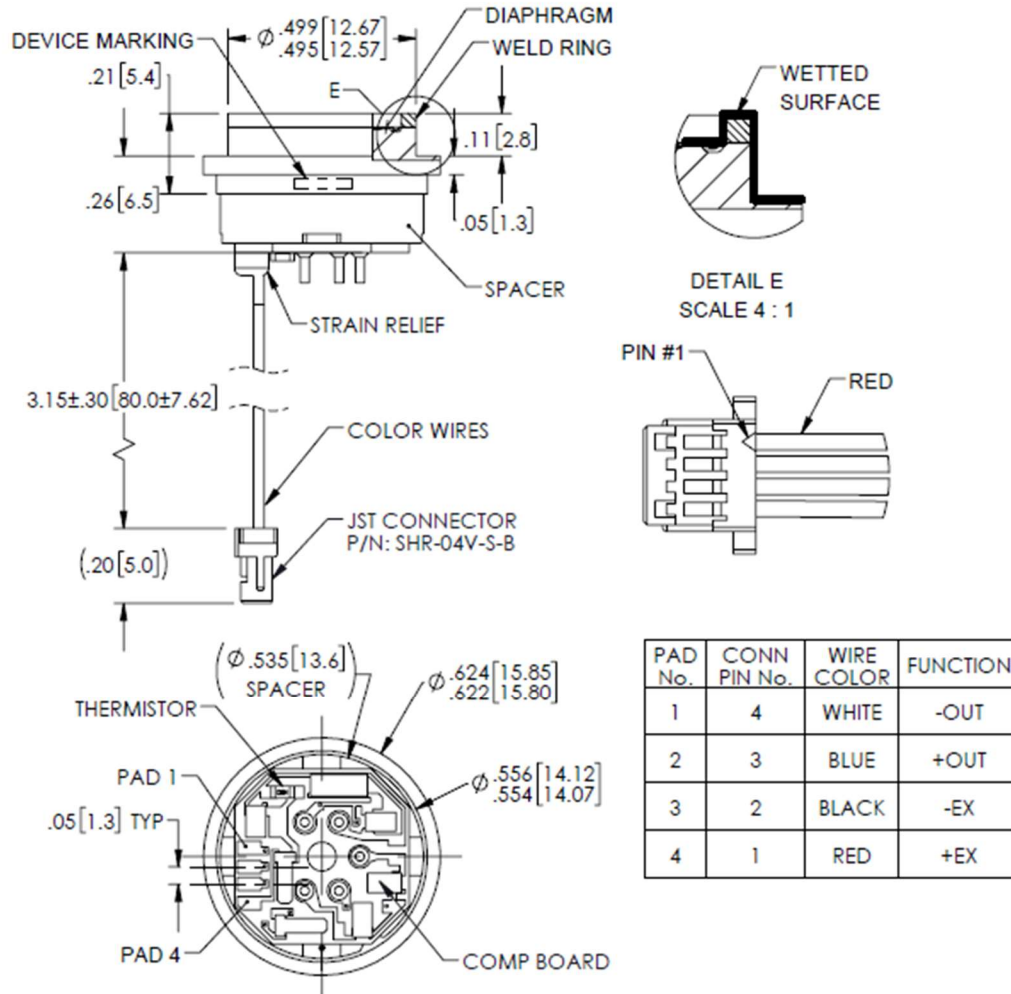
1. Tested at 0.25PSIA and full pressure range, then calculated to 0 PSIA.
2. Best fit straight line.
3. Over the compensated temperature range with respect to 25°C.
4. Guarantees output/input ratiometricity.
5. Load resistance to reduce measurement errors due to output loading.
6. Between case and sensing element.
7. The maximum pressure that can be applied without changing the transducer's performance or accuracy.
8. The maximum pressure that can be applied to a transducer without rupture of either the sensing element or transducer.
9. Maximum temperature range for product with standard cable and connector is -20°C to +85°C.
10. Device Marking:
Each part shall be identified with Model Number, Pressure Range, Type, Lot Number, Serial Number and Date Code
11. Shipping/Packaging
The diaphragm is protected by a plastic cap. 32pcs units are secured in a shipping tray vacuumized with ESD bag.
12. Direct mechanical contact with diaphragm is prohibited. Diaphragm surface must remain free of defects (scratches, punctures, dents, fingerprints, etc.) for device to operate properly. Caution is advised when handling parts with exposed diaphragms. Use protective cap whenever devices are not in use.
13. Wetted surface:
 - 13.1 The diaphragm, weld ring and module material (316L SS and Alloy C276) optional, C276 material is Compliant with SEMI F105.
 - 13.2 Indicated wetted surface (not including the welding bead) roughness optional.

85UHP

Ultra-high Purity ISO Pressure Capsule

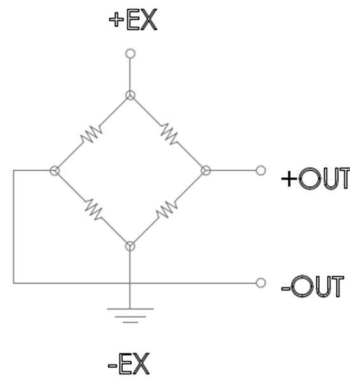
DIMENSIONS - Constant Voltage Compensated

Dimensions are in inches[mm]



VIEW SHOWN W/O CABLE AND CONNECTOR FOR CLARITY

APPLICATION SCHEMATIC - Constant Voltage Compensated



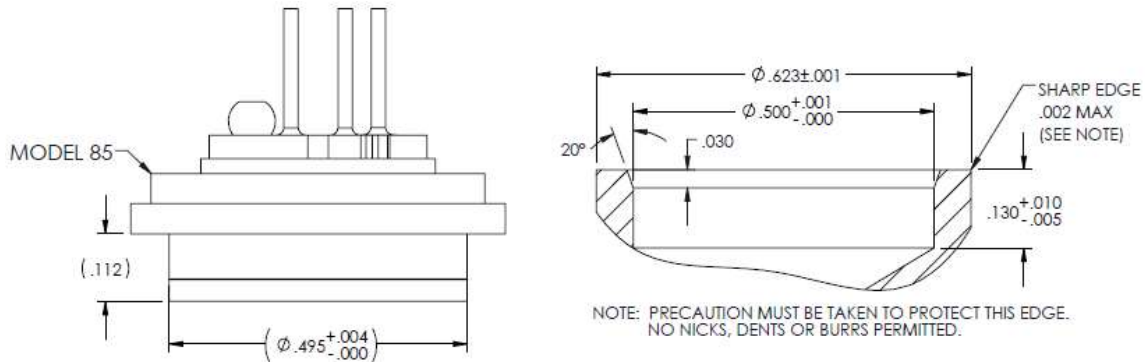
EQUIVALENT SCHEMATIC

85UHP

Ultra-high Purity ISO Pressure Capsule

RECOMMENDED MOUNTING DIMENSIONS

Unit: inches



ORDERING INFORMATION

Model:

85UHP	-	050	A	-	C	S	1	C
Model	-	Pressure Range (PSI)	Pressure Type	-	Compensated	Wetted Surface Material	Wetted Surface Roughness	Electrical
85 Ultra-high Purity	-	015 030 050 100	A = Absolute	-	U = Open Bridge, Uncompensated V = Constant Voltage Compensated C = Constant Current Compensated	S = 316L SS C = Alloy C276	1 = Ra32	Blank for Uncompensated C = Cable w/ Connector, L80mm

Part Number Family:

Part Number	Model/ Description	Part Number	Model/ Description	Part Number	Model/ Description
20032150-00	85UHP-015A-US1	20032150-10	85UHP-015A-VS1C	20032150-30	85UHP-015A-CS1C
20032150-01	85UHP-030A-US1	20032150-11	85UHP-030A-VS1C	20032150-31	85UHP-030A-CS1C
20032150-02	85UHP-050A-US1	20032150-12	85UHP-050A-VS1C	20032150-32	85UHP-050A-CS1C
20032150-03	85UHP-100A-US1	20032150-13	85UHP-100A-VS1C	20032150-33	85UHP-100A-CS1C
20032150-04	85UHP-015A-UC1	20032150-14	85UHP-015A-VC1C	20032150-34	85UHP-015A-CC1C
20032150-05	85UHP-030A-UC1	20032150-15	85UHP-030A-VC1C	20032150-35	85UHP-030A-CC1C
20032150-06	85UHP-050A-UC1	20032150-16	85UHP-050A-VC1C	20032150-36	85UHP-050A-CC1C
20032150-07	85UHP-100A-UC1	20032150-17	85UHP-100A-VC1C	20032150-37	85UHP-100A-CC1C

For other configurations, please consult TE.

本文件数据仅供技术培训人员使用。

客户技术部门负责评估产品对预期应用的适用性，以及本文件中给出的与此类应用相关的产品信息完整性。有关产品、技术、交货条款和条件以及价格的更多信息，请联系公司最近办公室。

由于产品版本升级或其他原因，本手册内容会不定期进行更新。

除非另有约定，本手册仅作为使用指导，本文档中的所有陈述，信息和建议不构成任何明示或暗示的担保。

中国大陆：西安鑫源宇通电子科技有限公司

陕西省西安市高新区科技六路西段西安国家数字出版基地A栋12402

邮箱：sales@senstechxyz.com

中国香港：深大实业有限公司

香港新界沙田安平街6号新贸易中心B座13楼06室

邮箱：info@caltropinstruments.com



关注公众号